O PE JOS DE LA PORTINA PORTINA

Ifw

PTO/SB/21 (09-04)
Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERC Le Pacerwork Reduction Act of 1995, no cersons are required to respond to a collection of information unless it displays a valid OMB control numb

Application Number	10/824,706	
Filing Date	04/15/2004	
First Named Inventor	RUECKES et al.	
Art Unit	2812	
Examiner Name	TBA	
Attorney Docket Number	112020.151US2 NAN-27	
	Filing Date First Named Inventor Art Unit Examiner Name	Filing Date 04/15/2004 First Named Inventor RUECKES et al. Art Unit 2812 Examiner Name TBA

			EN	CLOSURES (Check all t	that apply))	
	Fee Transmittal Form Fee Attached Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Reply to Missing Parts/ Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.53		Ren	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Ad Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on CD narks 1. PTO Form 1449 (5 pgs 2. 35 Publications	n ddress		After Allowance Communication to TC Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below): Postcard
		SIGNA	TURE	OF APPLICANT, ATTOR	RNEY, O	R AG	ENT
Firm N	lame	Wilmer Cutler Picke	ring Ha	ale and Dorr LLP			
Signature		کوه	Emp				
Printed name			Pete	M. Dichiara			
Date		3-3	30 -	OS R	Reg. No.		38,005

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below: Signature Tipped or printed name Tina M. Dougal Date 3 - 30 - 05

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

RUECKES et al.

Serial No.:

10/824,706

Examiner:

TBA

Filed:

April 15, 2004

Group Art Unit: 2812

For:

Process For Making Bit Selectable Devices Having Elements

Made With Nanotubes

Atty. Docket No.:

112020.151 US2 NAN-27

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 30, 2005.

Tina M. Dougal

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Applicants and their legal representatives hereby make of record on the attached Form PTO-1449 the following publications which are known to them and considered warranting disclosure under 37 C.F.R. §1.56 and 1.97-98.

Copies of the publications listed on the attached Form PTO-1449, with the exception of U.S. patents and U.S. patent publications, are submitted herewith. It is respectfully requested that the Examiner initial and return a copy of the subject Form PTO-1449 with the next Patent Office communication.

The submission of these publications does not constitute a representation by the Applicants that a search has been made or that no better art exists and does not constitute an admission that the listed publications are material or constitute "prior art." Applicants reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed publications, should one or more of the publications be applied against the claims of the present application.

As the Information Disclosure Statement is being filed prior to the mailing date of the first Office Action on the merits, no fee is believed to be due. However, in the event a fee is due, please charge any fee deficiency or credit any overpayment to Deposit Account No. <u>08-0219</u>.

Respectfully submitted,

Dated: March <u>30</u>, 2005

Peter M. Dichiara Registration No. 38,005 Attorney for Applicants

Wilmer Cutler Pickering Hale and Dorr LLP 60 State Street Boston, Massachusetts 02109

Tel: (617) 526-6466 Fax: (617) 526-5000

PTO/SB/08A (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no person are required to respond to a collection of information unless it contains a valid OMB control number.

Unus Sestitute for 1449/PTO Complete if Known Application Number 10/824,706 NEDRMATION DISCLOSURE Filing Date April 15, 2004 INTEMENT BY APPLICANT First Named Inventor RUECKES et al. (Use as many sheets as necessary) Art Unit 2812 **Examiner Name** TBA Attorney Docket Number 112010.151US2 NAN-27 Sheet 1 of 5

	1 2		S. PATENT DOCUM		De Colombia Linea
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ^{2(If known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US 2002/0130311 A1	09-19-2002	LIEBER et al.	Of Helevant Figures Appear
		US 2002/0130353 A1	09-19-2002	LIEBER et al.	
		US 2002/0172963 A1	11-21-2002	KELLEY et al.	
		US 2002/0179434 A1	12-05-2002	DAI et al.	
		US-2003/0021966 A1	01-30-2003	SEGAL et al.	
	<u> </u>	US-2003/0124325 A1	07-30-2003	RUECKES et al.	
		US-2003/0165074 A1	09-04-2003	SEGAL et al.	
		US-2003/0234407 A1	12-25-2003	VOGELI et al.	
		US-2003/0236000 A1	12-25-2003	VOGELI et al.	
		US-2004/0085805 A1	05-06-2004	SEGAL et al.	
		US-2004/0159833 A1	08-19-2003	RUECKES et al.	
		US-2004/0164289 A1	08-26-2003	RUECKES et al.	
		US-2004/0175856 A1	09-09-2004	JAIPRAKASH et al.	
		US-2004/0181630 A1	09-16-2004	JAIPRAKASH et al.	
		US-2004/0191978 A1	09-30-2004	RUECKES et al.	
		US-2004/0214366 A1	10-28-2004	SEGAL et al.	
		US-2004/0214367 A1	10-28-2004	SEGAL et al.	
		US-2005/0047277 A1	03-03-2005	RUECKES et al.	
		US-2005/0041465 A1	02-24-2005	RUECKES et al.	
		US-2005/0041566 A1	02-24-2005	RUECKES et al.	
		US-2005/0056877 A1	03-17-2005	RUECKES, et al.	
		US-3,448,302	06-03-1969	SHANEFIELD	
		US-4,845,533	07-04-1998	PRYOR et al.	
		US-4,853,893	08-01-1989	EATON et al.	
		US-4,876,667	10-24-1989	ROSS, et al.	
		US-4,888,630	12-19-1989	PATERSON	

Examiner	Date
Signature	Considered

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 'Applicant's unique citation designation number (optional). 'See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. 'Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 'For Japanese patent documents, the indication of the year of the Emperor must precede the serial number of the patent document. 'Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 'Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is established to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 20313-1450. VA 22313-1450.

Under the Paperwork Reduction Act of 1995, no person are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute fo	or form 1449/PTO			to receive to respond to a conscitor of	Complete if Known		
				Application Number	10/824,706		
			ISCLOSURE	Filing Date	April 15, 2004		
	STATEMEN	T BY	APPLICANT	First Named Inventor	RUECKES et al.		
	(Use as man	y sheets	as necessary)	Art Unit	2812		
				Examiner Name	TBA		
Sheet	2	of	5	Attorney Docket Number	112010.151US2 NAN-27		

US-4,888,630	12-19-1989	PATERSON
US-5,198,994	03-30-1993	NATORI
US-6,044,008	03-28-2000	CHOI
US-6,048,740	04-11-2000	HSU et al.
US-6,128,214	10-03-2000	KUEKES et al.
US-6,159,620	12-12-2000	HEATH et al.
US-6,183,714	02-06-2000	SMALLEY et al.
US-6,198,655	03-06-2001	HEATH et al.
US-6,221,330 B1	04-24-2001	MOY et al.
US-6,232,706	05-15-2001	DAI et al.
US-6,445,006	09-03-2002	BRANDES et al.
US-6,518,156 B1	02-11-2003	CHEN
US-6,548,841	04-15-2003	FRAZIER et al.
US-6,559,468 B1	05-06-2003	KUEKES et al.
US-6,574,130	09-04-2003	SEGAL et al.
US-6,643,165	11-04-2003	SEGAL et al.
US-6,673,424 B1	01-06-2004	LINDSAY
US-6,706,402	03-16-2004	RUECKES et al.
US-6,750,471B2	06-15-2004	BETHUNE et al.
US-6,759,693	07-06-2004	VOGELI et al.
US-6,774,052	08-10-2004	VOGELI et al.
US-6,781,166 B1	08-24-2004	LIEBER et al.
US-6,784,028	08-31-2004	RUECKES et al.
US-6,803,840	10-12-2004	HUNT et al.
US-6,809,465	10-26-2004	JIN
US-6,835,591	12-28-2004	RUECKES et al.

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is established to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Under the Paperwork Reduction Act of 1995, no person are require

Substitute fo	or form 1449/PTO			Complete if Known			
	INICODMATI	ÓN D	1001 00110=	Application Number	10/824,706		
INFORMATION DISCLOSURE		Filing Date	April 15, 2004				
			APPLICANT	First Named Inventor	RUECKES et al.		
	(Use as man	y sheets i	as necessary)	Art Unit	2812		
	T			Examiner Name	TBA		
Sheet	3	of	5	Attorney Docket Number	112010.151US2 NAN-27		

	FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite	Document Number	Publication Date	Name of Patentee or Applicant	Pages, Columns, Lines,			
Initials* No.1		Number-Kind Code ^{2(If known)}	MM-DD-YYYY	of Cited Document	Where Relevant Passages or Relevant Figures Appea			
	T		1	Doord of Town				
		WO 01/44796 A1	06-21-2001	Board of Trustees of				
		W 0 01/44/50 M1	00-21-2001	the Leland Stanford				
	+			Junior University				
		WO 01/03208	01-11-2001	President and Fellows				
			01 11 2001	of Harvard College				
		WO 2003/091486	11-06-2003	Nantero, Inc.				
		WO 2004/065655	08-05-2004	Nantero, Inc.				
		WO 2004/065657	08-05-2004	Nantero, Inc.	-			
		WO 2004/065671	08-05-2004	Nantero, Inc.				

		NON PATENT LITERATURE DOCUMENTS	0
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, volume-issue number(s), page(s), publisher, city and/or country where published.	T ²
	A1	AJAYAN, P.M., et al., "Nanometre-size tubes of carbon," Rep. Prog. Phys., 1997, Vol. 60, pp. 1025-1062.	
	A2	AMI, S. et al., "Logic gates and memory cells based on single C ₆₀ electromechanical transistors," Nanotechnology, 2001, Vol. 12, pp. 44-52.	
	A3	AVOURIS, Ph., "Carbon nanotube electronics," Carbon, 2002, Vol. 14, pp. 1891-1896.	
	A4	CASAVANT, M.J. et al., "Neat macroscopic membranes of aligned carbon nanotubes," Journal of Appl. Phys., 2003, Vol. 93(4), pp. 2153-2156.	
	A5	CHOI, WB. et al., "Carbon-nanotube-based nonvolatile memory with oxide- nitride-film and nanoscale channel," Appl. Phys. Lett., 2003, Vol. 82(2), pp. 275- 277.	
	A6	CUI, J.B. et al., "Carbon Nanotube Memory Devices of High Charge Storage Stability," Appl. Phys. Lett., 2002, Vol. 81(17), pp. 3260-3262.	
	A7	DAI, H. et al., "Controlled Chemical Routes to nanotube Architectures, Physics, and Devices," J. Phys. Chem. B, 199, Vol. 103, pp. 111246-11255.	

F			
Examiner		Date	
Cianatura	•	Date	
Signature		Considered	
*EVANIALED.	22-136	Donoidered	1

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 'Applicant's unique citation designation number (optional). 'See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. 'Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 'For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 'Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 'Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 197 and 198. The information is considered.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is established to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no person are required to respond to a collection of information unless it contains a valid OMB control number

Substitute fo	or form 1449/PTO			e required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known			
				Application Number	10/824,706		
	INFORMAT			Filing Date	April 15, 2004		
	STATEMEN			First Named Inventor	RUECKES et al.		
	(Use as mai	ny sheets as	necessary)	Art Unit	2812		
				Examiner Name	TBA		
Sheet	4	of	5	Attorney Docket Number	112010.151US2 NAN-27		

		DEHON, A., "Array-Based Architecture for FET-Based, Nanoscale Electronics,"		
	A8	IEEE Transactions on Nanotechnology, 2003, Vol. 2(1), pp. 23-32.		
		DEQUESNES, M. et al., "Calculation of pull-in voltages for carbon-nanotube-based		
	A9	nanoelectromechanical switches," Nanotechnology, 2002, Vol. 13, pp. 120-131.		
		DEQUESNES, M. et al., "Simulation of carbon nanotube-based		
	A10	nanoelectromechanical switches," Computational Nanoscience and		
		Nanotechnology, 2002, pp. 383-386.		
		FAN, S. et al., "Carbon nanotube arrays on silicon substrates and their possible		
	A11	application," Physica E, 2000, Vol. 8, pp. 179-183.		
	A12	FARAJIAN, A. A. et al., "Electronic transport through bent carbon		
		nanotubes: Nanoelectromechanical sensors and switches," Phys. Rev.		
		B, 2003, Vol. 67, pp. 205423-1 = 205423-6.		
_		FISCHER, J.E. et al., "Magnetically aligned single wall carbon nanotube films:		
	A13	Preferred orientation and anisotropic transport properties," Journal of Appl. Phys.,		
		2003, Vol. 93(4), pp. 2157-2163.		
A14		FRANKLIN, N. R. et al., "Integration of suspended carbon nanotube arrays into		
	A14	electronic devices and electromechanical systems," Appl. Phys. Lett., 2002,		
		Vol. 81 (5), pp. 913-915.		
	l	FUHRER, M.S. et al., "High-Mobility Nanotube Transistor Memory," Nano Letters,		
	A15	2002, Vol. 2(7), pp. 755-759.		
		HOMMA, Y. et al., "Growth of Suspended Carbon Nanotubes Networks on 100-		
	A16	nm-scale Silicon Pillars," Appl. Phys. Lett., 2002, Vol. 81(12), pp. 2261-2263.		
		KINARET, J.M. et al., "A carbon-nanotube-based nanorelay," Appl. Phys. Lett.,		
	A17	2003, Vol. 82(8), pp. 1287-1289.		
		LEE, KH. et al., "Control of growth orientation for carbon nanotubes," Appl, Phys.		
	A18	Lett., 2003, Vol. 82(3), pp. 448-450.		
		RADOSAVLIEVIC, M. et al., "Nonvolatile molecular memory elements based on		
	A19	ambipolar nanotube field effect transistors," Nano Letters, 2002, Vol. 2(7), pp. 761-		
		764.		
		ROBINSON, L.A.W., "Self-Aligned Electrodes for Suspended Carbon Nanotube		
	A20			
	RUECKES, T., et al., "Carbon Nanotube-Based Nonvolatile Random Access			
	A21	Memory for Molecular Computing" Science, 2000, Vol. 289, pp. 94-97.		
		SOH, H. T. et al., "Integrated nanotube circuits: Controlled growth and ohmic		
	A22	contacting of single-walled carbon nanotubes," Appl. Phys. Lett., 1999, Vol. 75(5),		
		pp. 627-629.		
aminer		Date		

Signature | Considered |
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. The indication of the document, by the two-letter code (WIPO Standard ST.3). For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is established to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

PTO/SB/08A (08-03)

Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no nen

Substitute fo	or form 1449/PTO			Complete if Known			
!	INICODIATI	ON 5	1001 00115=	Application Number	10/824,706		
}			ISCLOSURE	Filing Date	April 15, 2004		
			APPLICANT	First Named Inventor	RUECKES et al.		
	(Use as man	y sheets i	as necessary)	Art Unit	2812		
		·		Examiner Name	TBA		
Sheet	5	of	5	Attorney Docket Number	112010.151US2 NAN-27		

	Т	CDETVINAAD TO A 1 400 1 11 11 0 1 1 11 11 11 11 11 11 11 11	
	400	SREEKUMAR, T.V., et al., "Single-wall Carbon Nanotube Films", Chem. Mater.	
	A23	2003, Vol. 15, pp. 175-178.	
		TANS, S. et al., "Room-temperature based on a single carbon nanotube," Nature,	
	A24	1998.Vol. 393, pp. 49-52.	
1		TOUR, J. M. et al., "NanoCell Electronic Memories," J. Am. Chem. Soc., 2003,	
	A25	Vol. 125, pp. 13279-13283.	
		VERISSIMO-ALVES, M. et al., "Electromechanical effects in carbon nanotubes:	
	A26	Ab initio and analytical tight-binding calculations," Phys. Rev. B, 2003, Vol. 67,	
		pp. 161401-1 = 161401-4.	
	A27	WOLF, S., Silicon Processing for the VLSI Era; Volume 2 – Process Integration, Multi-Level-Interconnect Technology for VLSI and ULSI, 1990, Section 4.3 Materials for Multilevel Interconnect Technologies, pp. 189-191, Lattice Press, Sunset Beach	
	A28	WOLF, S., Silicon Processing for the VLSI Era; Volume 2 – Process Integration, 1990, Section 4.7 Manufacturing Yield and Reliability Issues of VLSI Interconnects, pp. 260-273, Lattice Press, Sunset Beach	
	A29	ZHAN, W., et al., "Microelectrochemical Logic Circuits,: J. Am. Chem. Soc., 2003, Vol. 125, pp. 9934-9935.	

Examiner	Date	
Signature	Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFB 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is established to take 2 hours to complete, including gathering, processy an application. Commontality is governed by 35 0.5.0. 122 and 37 OFF 1.14. This conection is established to take 2 hours to complete, including gallioning, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.